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SERIAL NUMBER 10/690,060	FILING DATE 10/21/2003  RULE	CLASS 438	GROUP ART UNIT 2825	ATTORNEY DOCKET NO. SC12967TP
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APPLICANTS

James N. Dougan, Round Rock, TX;

Lesley A. Smith, Austin, TX;

\*\* CONTINUING DATA \*\*\*\*\* *None*

\*\* FOREIGN APPLICATIONS \*\*\*\*\* *None*

IF REQUIRED, FOREIGN FILING LICENSE  
 GRANTED  
 \*\* 01/26/2004

Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR  COUNTRY TX	SHEETS  DRAWING 1	TOTAL  CLAIMS 29	INDEPENDENT  CLAIMS 3
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Verified and  
Acknowledged

*Examiner's Signature* *CE*  
 Examiner's Signature Initials

ADDRESS  
 23125  
 FREESCALE SEMICONDUCTOR, INC.  
 LAW DEPARTMENT  
 7700 WEST PARMER LANE MD:TX32/PL02  
 AUSTIN , TX  
 78729

TITLE  
 Method of forming a low K dielectric in a semiconductor manufacturing process

FILING FEE  RECEIVED 932	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing )
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